

INVENTOR INFORMATION

10/555141

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APPLICATION INFORMATION

Title Line One:: METHOD FOR TEXTURING SURFACES OF SILICON
Title Line Two:: WAFERS
Total Drawing Sheets:: 2
Formal Drawings?: Yes
Application Type:: Utility
Docket Number:: RAC0082
Secrecy Order in Parent Appl.?: No

REPRESENTATIVE INFORMATION

Representative Customer Number:: 832

CONTINUITY INFORMATION

This application is a:: 371 OF
> Application One:: PCT/DE04/00835
Filing Date:: 04-22-2004
Patent Number:: WO04/100244A1

PRIOR FOREIGN APPLICATIONS

Foreign Application One:: 103 202 212.9
Filing Date:: 05-07-2003
Country:: Germany
Priority Claimed:: Yes
Source:: PrintEFS Version 1.0.1